

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Jin Zhao Confirmation No.: 4854
Application Number : 10/623,757
Filed : July 21, 2003
Title : MAINTAINING A REACTOR CHAMBER OF A CHEMICAL VAPOR DEPOSITION SYSTEM
TC/Art Unit : 4151
Examiner: Smith, Francis P.

Docket No. : TI-35855 (0025.0220)
Customer No. : 23494

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT

In reply to the Office Action mailed December 26, 2007, please amend the above-identified application as follows:

Amendments to the Claims begin at page 2 of this paper.

Remarks/Arguments begin at page 13 of this paper.